

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 1821**
Mitsuhiro OKUNE et al. : Attorney Docket No. 2006_0772A
Serial No. 10/581,256 : Group Art Unit 1792
Filed May 31, 2006 : Examiner Mahmoud Dahimene
PLASMA ETCHING METHOD : **Mail Stop AF**

AMENDMENT UNDER 37 CFR § 1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action mailed December 24, 2008, please amend the above-identified application as follows.

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